# **SIEMENS**

# Exploring Opcenter Execution Semiconductor / Opcenter Execution Semiconductor功能培训 (基础) (F5203)

### **Objectives**

This course provides a basic understanding of the out of the boxcapability and functionality of the Opcenter Execution Semiconductor product. It guides you on how to:

- Configure a Factory Model.

- Expand the basic model to provide material control, resource tracking, task processing, data collection, equipment reservations, and more.

- Navigate the Portal pages as you learn the transactions available for processing work within your model.

- Configure and tailor the solution to fit your specific project requirements.

# Target Group

All core members of the implementation team

#### Content

- Introduction to Opcenter Execution Semiconductor
- Navigating the Portal Interface
- Explaining the Base-Initial Setups
- Controlling Login ; Security
- Utilizing Portal Studio
- Modeling
- Understanding the Modeling Structure
- Understanding the Modeling Sequence
- Implementing the Factory Information Model
- Configuring WIP Tracking, Products and Lots
- Modeling with Excel Spreadsheets
- Modeling the Workflow
- Planning and Scheduling in Opcenter EX Semiconductor
- Inventory Control
- Scheduling Control
- Managing WIP Processing in Opcenter EX Semiconductor
- WIP Control
- Use of Insertion Control and Virtual Qty
- WIP Processing
- Executing Ad Hoc Transactions
- Managing Resources in Opcenter EX Semiconductor
- Introduction to Resource Management
- Implementing Maintenance
- Implementing Parts Management
- Implementing Job Control
- Managing Resources in Opcenter EX Semiconductor
- Implementing Tool Control
- Implementing Mask Control
- Expanding Factory Model in Opcenter EX Semiconductor
- Accessing Information
- Using Electronic Procedures/Check Sheet
- Using Service Attributes
- Using WIP Data Collection and Calculation
- Using Equipment Schedule Reservation
- Implementing Yield Calculations

# Туре

Face-to-face training

#### Duration

4 days

# Language

zh

# Fee

10,000 CNY